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TRANSMITTAL FORM			Application Number	10/784	10/784,211 02-24-2004 Takashi FUJII		
			Filing Date	02-24-			
			First Named Inventor	Takasi			
			Art Unit	1734	1734		
(to be used for all correspondence after initial filing)			Examiner Name	J. Sells	J. Sells		
			Attorney Docket Number	46379	46379		
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ENCLOSURES (Check all that apply)							
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Fee Attached				Licensing-related Papers			of Appeals and Interferences
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SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT							
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Date 04-27-2006				Reg. No.	Reg. No. 32,023		
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46379

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Takashi FUJII et al. : Group Art Unit: 1734

Serial No.: 10/784,211 : Examiner: J. Sells

Filed: February 24, 2004

For: PROCESS FOR PRODUCING COLD

FIELD EMISSION CATHODES

## **RESPONSE AFTER FINAL**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This is in response to the January 27, 2006 Office Action.

In the Action, claims 1-34 are rejected. In view of the following comments, reconsideration and allowance are requested.

## Rejection of Claims 1-34

Claims 1-34 are rejected under 35 U.S.C. § 103(a) as being obvious over U.S. Patent No. 6,097,138 to Nakamoto in view of U.S. Patent No. 6,436,221 to Chang et al. Nakamoto is cited for disclosing a field emission cold cathode device by forming nanotubes on a substrate and then applying a conductive material over the nanotubes and the substrate. Chang et al. is cited as allegedly disclosing a taping method to remove a portion of the carbon nanotubes from a substrate. The rejection is based on the position that it would have been obvious to modify the process of Nakamoto according to Chang et al. to include a taping